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PATENT 03345-P0017A WWW/GJL

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Michael Heuken, et al.
Serial No. 09/873,041	Filing Date: June 1, 2001
Title of Application:	Method And System For Semiconductor Crystal Production With Temperature Management
Confirmation No. 5097	Art Unit: 1765
Examiner	Matthew J. Song

wMail Stop Non-Fee Amendment Commissioner for Patents Post Office Box 1450 Alexandria, VA 22313-1450

## Response to Notice of Non-Compliant Preliminary Amendment (37 C.F.R. §1.121) in Request for Continued Examination Under 37 C.F. R. §1.114

In response to the Notice of Non-Compliant Amendment (37 CFR 1.121) mailed on January 8, 2004 in the above Request for Continued Examination, Applicants herewith present compliant Amendments and Remarks in the above U.S. patent application. Please amend the Claims as set forth below.

<u>Mailing Certificate</u>: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner for Patents and Trademarks; Post Office Box 1450; Alexandria, VA 22313-1450.

February 6, 2004

Caroline Gahagan